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10588981 - GAI: 2881

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	Filing Date		2006-08-10	
	First Named Inventor	RODERICK BOSWELL		
	Art Unit	2881		
	Examiner Name	NOT YET ASSIGNED		
	Attorney Docket Number	F146		

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/M.S./	1	LEUNG, KA-NGO, "Plasma sources for electrons and ion beams," J. Vac. Sci, Technology B, Nov/Dec 1999, Vol. 17, No. 6., pages 2776-2778. Nov. 1999	<input type="checkbox"/>
/M.S./	2	MATHEW, JOSE V., ET AL., "Subcutoff microwave driven plasma ion sources for multielemental focused ion beam systems," Review of Scientific Instruments, 2008, Vol 79, 5 pages. June, 2008	<input type="checkbox"/>
/M.S./	3	ONO, L.K., ET AL., "A Compact Gas Cluster Ion Beam Source of QSEC," 2003, 4 pages.	<input type="checkbox"/>
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